

*Petition
accept p 8
3-30-99*
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

jc525 U.S. PTO
09/259145
02/26/99

In re Application of:

Pan, et al.

Serial No.: To be assigned

Filed: February 26, 1999

**For: WELL-DRIVE ANNEAL TECHNIQUE
USING PREPLACEMENT OF NITRIDE
FILMS FOR ENHANCED FIELD
ISOLATION**

Examiner: To be assigned

Group Art Unit: To be assigned

Attorney Docket No.: 3027.1US(96-0684.1)

NOTICE OF EXPRESS MAILING

Express Mail Mailing Label Number: EL248175148US
Date of Deposit with USPS: February 26, 1999
Person making Deposit: Jared Turner

PETITION TO ACCEPT PHOTOGRAPHS AS DRAWINGS (37 C.F.R. § 1.84(b))

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

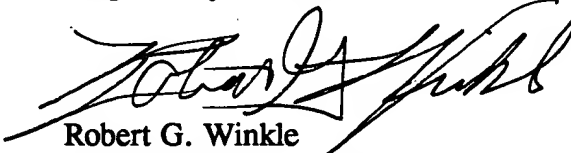
Petition is hereby made to accept photographs in this case. Three (3) sets of photographs are submitted herewith. The reason why photographs are necessary in this case is as follows:

For clear illustration of the effects of the present invention, scanning electron micrographs have been taken of the semiconductor device with and without utilizing the present invention.

03/11/1999 JWASHINGTON 00000001 20369
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A check in the sum of \$130.00 is attached in payment of petition fee (37 C.F.R. § 1.17(i)). Please charge Account No. 20-1469 for any fee deficiency, or credit said Account for any overpayment.

Respectfully submitted,



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Attorney for Applicants
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Date: February 26, 1999

RGW/kf

Enclosures: Three (3) sets of photographs
Check in the amount of \$130.00